

Docket No.: A-69175-1/MSS (463035-650)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named

Inventor:

Nam P. Suh et al.

Appln. No.:

10/029,158

Filing Date:

December 21, 2001

APPARATUS AND METHOD FOR

CHEMICAL MECHANICAL

Title:

POLISHING OF SUBSTRATES

RACHUBA,

Examiner:

Maurina T.

Group Art Unit:

3723

PETITION FOR EXTENSION OF PERIOD FOR RESPONSE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.136(a), Applicant hereby petitions for an extension of 1month(s) (from November 18, 2004 to December 18, 2004 within which to respond to the Notice of Non-Compliance Amendment dated October 18, 2004. A check in the amount of \$120.00 (\$120.00 for 1 month extension fee for large entity) is enclosed herewith to cover the extension fee. Please charge any additional fees or credit any overpayment to our Deposit Account No. 50-2319 (Order No. A-69175-1/MSS (463035-650)).

> Respectfully submitted, DORSEY & WHITNEY LLP

Date: December 17, 2004

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120.00 GP

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